

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: )  
)  
NISHIMOTO et al ) Art Unit: 2823  
)  
Serial No.: 08/897,839 ) Examiner: K. Eaton  
)  
Filed: July 21, 1997 )  
)  
For: STRESS-ADJUSTED INSULATING )  
FILM FORMING METHOD, )  
SEMICONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING THE )  
SAME )

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

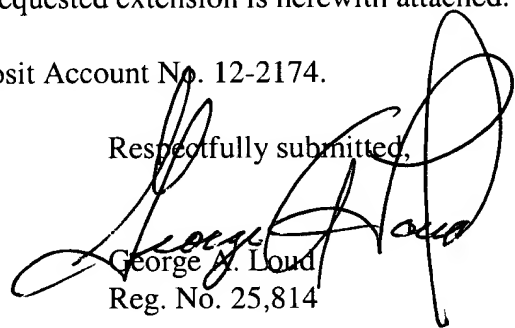
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time period for filing a response to the office action of April 7, 2003, initially set to expire July 7, 2003, be extended one month up to and including August 7, 2003. The requisite \$110.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

Respectfully submitted,



George A. Loud  
Reg. No. 25,814

08/08/2003 CNGUYEN 00000053 08897839  
01 FC:1251 110.00 OP

Date: August 7, 2003  
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